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CONFIRMATION NO. 1365

<b>SERIAL NUMBER</b> 10/765,613	<b>FILING OR 371(c) DATE</b> 01/27/2004 <b>RULE</b>	<b>CLASS</b> 451	<b>GROUP ART UNIT</b> 3723	<b>ATTORNEY DOCKET NO.</b> INK-001
<b>APPLICANTS</b> In Kwon Jeong, Cupertino, CA;				
<b>** CONTINUING DATA *****</b> This appln claims benefit of 60/442,952 01/27/2003 and claims benefit of 60/461,147 04/08/2003 and claims benefit of 60/462,015 04/11/2003 and claims benefit of 60/464,280 04/21/2003 and claims benefit of 60/466,587 04/30/2003 and claims benefit of 60/468,239 05/05/2003 and claims benefit of 60/468,561 05/06/2003 and claims benefit of 60/477,489 06/10/2003				
<b>** FOREIGN APPLICATIONS *****</b>				
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED-- SMALL ENTITY **</b> <b>** 06/11/2004</b>				
Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> not after Allowance Examiner's Signature: [Signature] Initials: [Initials]	<b>STATE OR COUNTRY</b> CA	<b>SHEETS DRAWING</b> 62	<b>TOTAL CLAIMS</b> 38
<b>INDEPENDENT CLAIMS</b> 8				
<b>ADDRESS</b> 30139				
<b>TITLE</b> Apparatus and method for polishing semiconductor wafers using one or more pivotable load-and-unload cups				
<b>FILING FEE RECEIVED</b> 762	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	